ABSTRACT

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| 2 | A method and apparatus are provided for identifying differences between a stored pattern |
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| 3 | and a matching image subset, where variations in pattern position, orientation, and size do not |
| 4 | give rise to false differences. The invention is also a system for analyzing an object image with |
| . 5 | respect to a model pattern so as to detect flaws in the object image. The system includes |
| 6 | extracting pattern features from the model pattern; generating a vector-valued function using the |
| 7 | pattern features to provide a pattern field; extracting image features from the object image; |
| 8 | evaluating each image feature, using the pattern field and an n-dimensional transformation that |
| 9 | associates image features with pattern features, so as to determine at least one associated feature |
| 10 | characteristic; and using at least one feature characteristic to identify at least one flaw in the |
| 11 | object image. The invention can find at least two distinct kinds of flaws: missing features, and |
| 12 | extra features. The invention provides pattern inspection that is faster and more accurate than |
| 13 | any known prior art method by using a stored pattern that represents an ideal example of the |
| 14 | object to be found and inspected, and that can be translated, rotated, and scaled to arbitrary |
| 15 | precision much faster than digital image re-sampling, and without pixel grid quantization errors. |
| 16 | Furthermore, since the invention does not use digital image re-sampling, there are no pixel |
| 17 | quantization errors to cause false differences between the pattern and image that can limit |
| 18 | inspection performance. |